



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

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Art Unit: 2814

Hisashi OHTANI et al.

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Examiner: P. Cao

Serial No. 09/550,598

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Filed: April 17, 2000

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For: SEMICONDUCTOR DEVICE

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AND PROCESS FOR

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PRODUCING THE SAME

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CERTIFICATE OF MAILING

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PRELIMINARY AMENDMENT

Honorable Commissioner of Patents

Washington, D.C. 20231

Sir:

In response to the Advisory Action dated September 9, 2002 please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 1-4, 14-15 and 28-29 as follows:

1. (Amended) A method for producing a semiconductor device having an active matrix display device, comprising:

forming a first conductive layer;

forming an insulating layer comprising an organic resin over said first conductive layer;

forming an opening in said insulating layer to expose said first conductive layer at a bottom of said opening;

forming an embedded conductive layer comprising an organic resin to cover said insulating layer and said opening;

etching or polishing said embedded conductive layer to expose a portion of the insulating layer; and

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S. Mailey
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